

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Confirmation No. 2042
Koichiro TANAKA et al.)	Group Art Unit: 2823
Serial No. 10/582,616)	Examiner: George R. Fourson III
Filed: June 12, 2006)	
For: LIGHT EXPOSURE APPARATUS)	
AND MANUFACTURING METHOD)	
OF SEMICONDUCTOR DEVICE)	
USING THE SAME)	

AMENDMENT AND RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.